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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/736,935	12/16/2003	Timothy Paul Bock	4-43-7	5534
Wanda W Wal	EXAM	EXAMINER		
Wendy W. Kol PO Box 556		AKANBI, ISIAKA O		
Springtown, PA	A 18081		ART UNIT	PAPER NUMBER
•			2877	
SHORTENED STATUTOR	RY PERIOD OF RESPONSE	MAIL DATE	DELIVER	Y MODE
3 MC	ONTHS	12/22/2006	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

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	Ap	plication No.	Applicant(s)	
		/736,935	BOCK ET AL.	
Office Action Summary		aminer	Art Unit	
	1	ika O. Akanbi	2877	
The MAILING DATE of this co Period for Reply	mmunication appears	on the cover sheet with the	he correspondence addres	ss
A SHORTENED STATUTORY PER WHICHEVER IS LONGER, FROM - Extensions of time may be available under the p after SIX (6) MONTHS from the mailing date of t - If NO period for reply is specified above, the may - Failure to reply within the set or extended period Any reply received by the Office later than three earned patent term adjustment. See 37 CFR 1.7	THE MAILING DATE rovisions of 37 CFR 1.136(a). his communication. if the state of t	OF THIS COMMUNICAT In no event, however, may a reply to ly and will expire SIX (6) MONTHS the application to become ARAND.	ION. De timely filed from the mailing date of this commu	
Status				
1)⊠ Responsive to communication	(s) filed on 31 Octobe	er 2006		
2a) This action is FINAL .	2b)⊠ This action			
3) Since this application is in con			prosecution as to the me	rits is
closed in accordance with the				
Disposition of Claims				
4)⊠ Claim(s) <u>1-14</u> is/are pending ir	the application			
4a) Of the above claim(s) 2 and	• •	n from consideration		
5) Claim(s) is/are allowed.		m nom consideration.	•	
6)⊠ Claim(s) <u>1,3-6 and 14</u> is/are re				
7) Claim(s) is/are objected		•		
8) Claim(s) are subject to		tion requirement.		
Application Papers		·		
9)☐ The specification is objected to	by the Examiner			
10)⊠ The drawing(s) filed on <u>31 July</u>		cepted or b)□ objected t	o by the Evaminer	-
Applicant may not request that an	y objection to the drawir	ng(s) be held in abevance	See 37 CFR 1 85(a)	
Replacement drawing sheet(s) inc				121(d)
11)☐ The oath or declaration is object	ted to by the Examin	er. Note the attached Offi	ice Action or form PTO-18	52.
Priority under 35 U.S.C. § 119				
12) ☐ Acknowledgment is made of a c a) ☐ All b) ☐ Some * c) ☐ None	claim for foreign priori of:	ty under 35 U.S.C. § 119	(a)-(d) or (f).	
 Certified copies of the pr 	iority documents have	e been received.		
2. Certified copies of the pr			ation No.	
Copies of the certified co				е
application from the Inter	national Bureau (PC	T Rule 17.2(a)).	·	
* See the attached detailed Office	action for a list of the	certified copies not recei	ived.	
• • • • • • • • • • • • • • • • • • • •				
Attachment(s)	•			
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Rev 	iew (PTO-948)	4) Interview Summa Paper No(s)/Mail		
3) Information Disclosure Statement(s) (PTO-14	149 or PTO/SB/08)	5) 🔲 Notice of Informa	l Patent Application (PTO-152)	
Paper No(s)/Mail Date		6)	·	
TOL-326 (Rev. 7-05)	Office Action Su	Jmmarv	Part of Paper No./Mail Date 200	061122

Application/Control Number: 10/736,935

Art Unit: 2877

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 31 October 2006 has been entered. Claims 2 and 7-13 are cancelled.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1, 3-5 and 14 are rejected under 35 U.S.C. 102(e) as being anticipated by Mehrl et al. (7,095,494 B2).

As regard to claim 1, Mehrl discloses an arrangement for controlling the alignment direction of a light beam comprising of the following:

an active light source (105) for emitting a beam of light (115), a passive receiver of light (120), a MEMS mirror (110) for receiving said beam of light from said active source and for reflecting said beam of light toward said passive receiver of light wherein said MEMS mirror is electrically controlled(150) to change its deflection profile until alignment is achieved between the active light source and the passive receiver of light (col. 10, line 58-60)(col. 11, line 28-37),

a monitoring photodiode(125) and a beam splitter (fig. 2) associated with the MEMS mirror to enable said MEMS mirror to split the beam emitted from said active light source into a first beam (205) and a second beam (212) wherein said first beam is directed toward the

Application/Control Number: 10/736,935

Art Unit: 2877

passive receiver of light and said second beam is directed toward said monitoring photodiode, wherein a power measurement of said second beam is converted to an electrical signal by the monitoring photodiode and used to electrically change the deflection profile of said MEMS mirror (figs. 1, 1A, and 2)(col. 9, line 30-col. 11, line 1-10).

As to claim 3, Mehrl discloses the beam splitter forms the first and second light beams to comprise a predetermined power ratio (fig. 2)(col. 9, line 12-30).

As to claim 4, Mehrl discloses monitoring photodiode (125) is operably connected to the active light source and to the MEMS mirror whereby a change in the strength of the first and second light beams causes the monitoring photodiode to generate the electrical signal used to change the deflection profile of the MEMS mirror (fig. 4)(col. 9, line 63-col. 10, line 1-25)(col. 10, line 33-43).

As to claim 5, Mehrl discloses a laser active light source (col. 2, line 50-53).

As regard to claim 14, Mehrl discloses an arrangement for continuously controlling the amount of light propagating through a single passive optical receiver comprising of the following:

a passive optical device (120) for propagating optical signals in both a transmitting and a receiving direction, an active light source (105); an alignment monitoring photodiode (125)(col. 9, line 34-38), a first and a second MEMS mirror (col. 9, line 47-48), said first MEMS mirror for reflecting a beam of light (205) from said active light source to said passive device and said second MEMS mirror for reflecting a beam of light (212) from said passive optical device to said monitoring photodiode; and a control circuit disposed between the alignment monitoring photodiode and said first and second MEMS mirrors (figs. 1 and 2)(col. 9, line 7-45), said control circuit (160) responding to changes in optical power received by said alignment monitoring photodiode and generating alignment correction signals to said first and second MEMS mirrors to modify the deflection profile of said first/and second MEMS mirrors and provide optical realignment between the passive optical device and the active light source (col. 10, line 35-60).

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and

Art Unit: 2877

the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over Mehrl et al. (7,095,494 B2) in view of Street et al. (6,760,505 B1).

Claim 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over of Street. The reference of Mehrl teaches of the features of claim 6, comprising a passive receiver of light (120). The reference of Mehrl is silent regarding an optical fiber passive receiver of light. The reference of Street teaches of passive receiver of light (160)(fig. 1). It would have been obvious to one having ordinary skill in the art at the time of invention to provide an optical fiber passive receiver of light for the purpose of transmitting signal to a remote system.

Additional Prior Art

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. The references listed in the attached form PTO-892 teach of other prior art alignment devices that may anticipate or obviate the claims of the applicant's invention.

Conclusion

Fax/Telephone Information

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Isiaka Akanbi whose telephone number is (571) 272-8658. The examiner can normally be reached on 8:00 a.m. - 4:30 p.m.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory J. Toatley Jr. can be reached on (571) 272-2059. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Art Unit: 2877

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Isiaka Akanbi November 22, 2006

Supervisory Patent Examiner